WEST Search History

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DATE: Tuesday, October 05, 2004

Hide?	Set Name	Query	Hit Count
		DB=USPT; PLUR=YES; OP=ADJ	
☐	L18	L14 and pin	1
☐	L17	L14 and pin	1
☐	L16	L14 and (liquid or fluid)	1
☐	L15	L14 and hydrophobic	0
☐	L14	6543080.pn.	1
		DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ	
☐	L13	L12 with (mov$4 or retreat$3)	5
☐	L12	(distance or space) between wafer adj3 chuck	82
☐	L11	distance between wafer adj3 chuck	24
☐	L10	wafer with chuck with mov$4 with (space or distance) with (liquid or fluid)	8
☐	L9	wafer and (chuck mov$4 up adj2 down)	22
☐	L8	L5 and retreat	6
☐	L7	L5 and (lower adj2 member)	2
☐	L6	L5 and holding member	27
☐	L5	L4 and substrate	100
☐	L4	L3 or l2	138
☐	L3	orii-takehiko$.in.	48
☐	L2	toshima-takayuki$.in.	103
		DB=USPT; PLUR=YES; OP=ADJ	
☐	L1	(6536452 OR 6613692 OR 6514073 OR 6634806 OR 6888020 OR 6513537)	5

END OF SEARCH HISTORY